

**B. TECH.**  
**THEORY EXAMINATION 2017-18**  
**ADVANCE SEMICONDUCTOR DEVICES**

Time: 3 Hours

Total Marks: 100

Note: Attempt all Sections. If require any missing data; then choose suitably.

**SECTION A**

- 1. Attempt all questions in brief. 2 x 10 = 20**
- a. Draw the energy level diagram of a PN junction.
  - b. Define mobility.
  - c. Give the expression for minority carrier life time.
  - d. What is contact potential?
  - e. Define depletion width.
  - f. The Si energy gap changes monotonically with temperature. What is the basic concept behind this?
  - g. Make the energy band diagram of a metal and semiconductor junction at equilibrium. Consider Al metal having a large work function and n-type semiconductor.
  - h. What is meant by IMPATT diode?
  - i. State three major differences between photodiode and solar cell.
  - j. Explain charge coupled device (CCD).

**SECTION B**

- 2. Attempt any three of the following: 10 x 3 = 30**
- a. Explain Zener and Avalanche Breakdown in p-n Junction.
  - b. What is meant by TRAPATT? Describe briefly the principle of operation of TRAPATT diode.
  - c. Explain Carrier life time, electron hole pair, recombination, diffusion length.
  - d. Explain construction and working of Backward Diode and The Schottkey Barrier Diode.
  - e. Explain the principle of operation, storage and transfer of charge in basic charge coupled device (CCD).

**SECTION C**

- 3. Attempt any one part of the following: 10 x 1 = 10**
- a. Write short notes on (i) Avalanche diode (ii) Fermi level
  - b. Give construction, working and application of solar cell.
- 4. Attempt any one part of the following: 10 x 1 = 10**
- a. Discuss operation, applications and symbol of Zener and Tunnel diode.
  - b. Explain Basic Structures and the Operating Principle with I-V Characteristics of MOSFET.
- 5. Attempt any one part of the following: 10 x 1 = 10**
- a. In a Si sample  $10^{13}$  EHP/cm<sup>3</sup> are created optically every microsecond with  $n_0=10^{14}$ /cm<sup>3</sup> and  $t_n=2\mu\text{sec}$  and  $t_p=1\mu\text{sec}$ . find steady state excess electron and hole concentrations and also estimate separation between quasi Fermi levels by showing in band diagrams.

- b. What is transferred electron effect? Describe a device based on this effect with suitable diagram in detail. Also draw its characteristics.

**6. Attempt any *one* part of the following: 10 x 1 = 10**

- a. What is photodetector? Explain the operation of a p-i-n photodetector. What are the suitable materials for it? How can it be made more sensitive to low level intensity of light?
- b. Draw a schematic diagram of TRAPATT diode and discuss its working principle. Calculate the avalanche-zone velocity for a TRAPATT diode having the acceptor doping concentration in the p-region  $N_a = 10^{15}/\text{cm}^3$  and current density  $J = 8 \text{ kA}/\text{cm}^2$ .

**7. Attempt any *one* part of the following: 10 x 1 = 10**

- a. Write short notes on
- i. Light Emitting Diodes
  - ii. Semiconductor Lasers.
- b. Derive the expression for Conductivity and Mobility and also the expression for Diffusion of carriers in semiconductors.